



#14

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: HENNHÖFER ET AL  
SERIAL NO.: 09/032,305 EXAMINER: R. KUNEMUND  
FILED: FEBRUARY 27, 1998 GROUP: 1765  
TITLE: PROCESS FOR TREATING A POLISHED SEMICONDUCTOR  
WAFER IMMEDIATELY AFTER THE SEMICONDUCTOR WAFER  
HAS BEEN POLISHED

PETITION UNDER RULE 136(a) AND RULE 17(a)(1)

ATTN: BOX CPA  
Assistant Commissioner for Patents  
Washington, D.C. 20231

RECEIVED  
OCT 12 2000  
TECHNOLOGY CENTER 1700

Dear Sir:

Applicants petition the Commissioner of Patents and Trademarks, under Rule 136(a), to extend the time for response to the Final Office Action dated JUNE 12, 2000 for one (1) month, from SEPTEMBER 12, 2000 to OCTOBER 12, 2000. Submitted herewith, under Rule 17(a)(1), is a check in the amount of \$110 to cover the cost of the extension for a Large Entity.

The Commissioner is hereby authorized to charge any additionally required fee, or to credit any overpayment, to our Deposit Account No. 03-2468.

Respectfully submitted,

HEINRICH HENNHÖFER ET AL

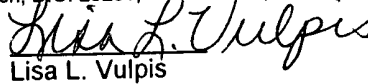


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Registration No. 26,048  
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Enclosures: Check in the amount of \$110

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: ASSISTANT COMMISSIONER OF PATENTS, Washington, D.C. 20231, on October 6, 2000.



Lisa L. Vulpis